

Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10709975	BEAN, RON M.
Examiner	Art Unit	
Urszula M Cegielnik	3711	

SEARCHED

Class	Subclass	Date	Examiner
446	207-209,397,193,418	7/18/2008	UMC

SEARCH NOTES

Search Notes	Date	Examiner

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner
	See EAST Text Search History	7/21/2008	UMC